

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application of:	)	
	)	
Takeshi SAKAMOTO et al.	)	Confirmation No.: 8322
	)	
U.S. Application No.: 10/594,907	)	Group Art Unit: 2895
	)	
Filed: August 7, 2008	)	Examiner: Michael Jung
	)	
For: LASER PROCESSING METHOD AND	)	
SEMICONDUCTOR CHIP	)	

Commissioner for Patents  
U.S. Patent and Trademark Office  
**Customer Window, Mail Stop Amendment**  
Alexandria, VA 22314

Sir:

**AMENDMENT**

In response to the non-final Office Action dated January 29, 2010, the period for response to which extends through July 29, 2010, by the concurrently-filed petition for a three-month extension of time and corresponding fee payment, please amend the above-identified application as follows: